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Attorney Docket No.: 0553-0152.02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
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YAMAZAKI et al.)
)
Serial No.: 10/684,936)
)
Filed: October 14, 2003)
)
For: Semiconductor Device And Method)
Of Fabricating The Same)
)
Examiner: Thien F. Tran)
)
)
Art Unit: 2811)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on <u>November 24, 2004</u> (Date of Deposit) <u>Shannon Wallace</u> Name of applicant, assignee, or Registered Rep. <u>Shannon Wallace</u> <u>11/24/04</u> Signature Date	
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

In response to the Office Action of August 24, 2004, please amend the above-identified application as follows: